CLAIMS

1. Resistor array comprising N lines of commands N_i , with i being a strictly positive integer, M columns of commands M_j , with j being a strictly positive integer, and NM resistors R_{ij} , each resistor R_{ij} being commanded by the line N_i and the column M_j , characterised in that at least one of the resistors has a negative thermal coefficient resistance and is associated with a thermally activatable component.

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- $\hbox{2. Array according to claim 1,} \\ \hbox{characterised in that each resistor R_{ij} is associated} \\ \hbox{with a thermally activatable component.}$
- 3. Array according to one of claims 1 or 2, wherein at least one of the activatable components is a microvalve.
- 4. Array according to one of claims 1 to 3, wherein all of the resistors R_{ij} have negative thermal coefficient resistances.
- 5. Array according to one of claims 1 to 4, characterised in that at least one of the negative thermal coefficient resistors is made of a single material.
- 6. Array according to claim 4, characterised in that all of the negative thermal 30 coefficient resistors are made of a single material.

- 7. Array according to one of claims 1 to 6, characterised in that all of the resistors are identical.
- 8. Array according to one of the previous claims, wherein the negative thermal coefficient resistor includes tantalum nitride, a nickel-chromium alloy, or a nitride from refractory material.
- 9. Array according to one of the previous claims, wherein the negative thermal coefficient resistor has a temperature coefficient of between -100 and -3000 ppm/°C.
- 10. Array according to any one of claims 1 to 9, characterised in that the material used for at least one line and/or at least one column has a positive thermal coefficient resistance.
- 20 11. Array according to claim 10, characterised in that all of the lines and/or all of the columns are made of a material with a positive thermal coefficient resistance.
- 12. Array according to one of claims 1 to 11, characterised in that all of the lines and all of the columns are made of the same material.
- 13. Array according to one of claims 1 to 30 12, which is associated with an insulating substrate.

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- 14. Array according to one of the previous claims, also including means for adjusting the time for which a command voltage is applied to at least one of the resistors R_{ij} , in particular to each resistor R_{ij} , so as to obtain the desired output.
- 15. Method for producing a resistor array, wherein at least one of the resistors is obtained by placing a resistive material (16), of which the resistance has a negative thermal coefficient, on a substrate (10) and including the association of this resistor with a thermally-activatable component.
- 16. Production method according to claim 15, including the deposition of the resistive material by cathode sputtering.
- 17. Production method according to one of claims 15 or 16, including the deposition of a conductive material (12) on the substrate (10) so as to form lines (14) before the resistive material is deposited.
- 18. Production method according to one of 25 claims 15 to 17, including the deposition of a conductive material (12) so as to form columns (24) after the resistive material has been deposited.
- 19. Method according to one of claims 15 to 30 18, including a step of depositing a material (20) insulating the lines from the columns on said substrate.

20. Method according to one of claims 17 to 19, including the choice of a material of which the resistance has a positive thermal coefficient for the lines and/or columns.

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- 21. Method according to one of claims 15 to 20, including the association of the array with a microvalve array.
- 10 22. Device for biological use, including an array according to one of claims 1 to 14, associated with a microfluidic array.